



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Mikihiko ISHII et al.

Application No.: 10/802,840

Docket No.: 119132

Filed: March 18, 2004

For: METHOD AND APPARATUS FOR POINT DIFFRACTION INTERFEROMETRY

**REQUEST FOR CORRECTION OF PALM RECORDS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records. A Supplemental Application Data Sheet is attached.

Respectfully submitted,

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Date: August 2, 2004

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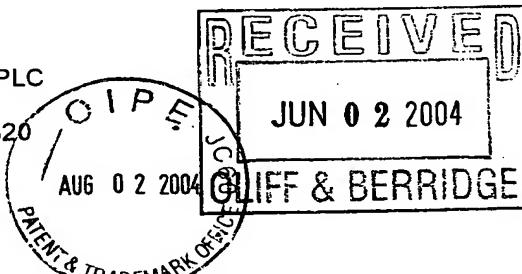


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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/802,840	03/18/2004		1186	119132	8	1	1

25944  
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CONFIRMATION NO. 5068  
 FILING RECEIPT



\*OC000000012823781\*

Date Mailed: 06/01/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment For Published Patent Application

NIKON CORPORATION, Tokyo, JAPAN;

Domestic Priority data as claimed by applicant

This application is a CON of PCT/JP02/10003 09/27/2002

Foreign Applications

JAPAN 2001-297902 09/27/2001

If Required, Foreign Filing License Granted: 05/29/2004

Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

**Title**

Method and apparatus for point diffraction interferometry

**Preliminary Class**

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Title 37, Code of Federal Regulations, 5.11 & 5.15**

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